

## Supporting information

For

### Effects of Ti-doping amount and annealing temperature on electrochromic performance of sol-gel derived WO<sub>3</sub>

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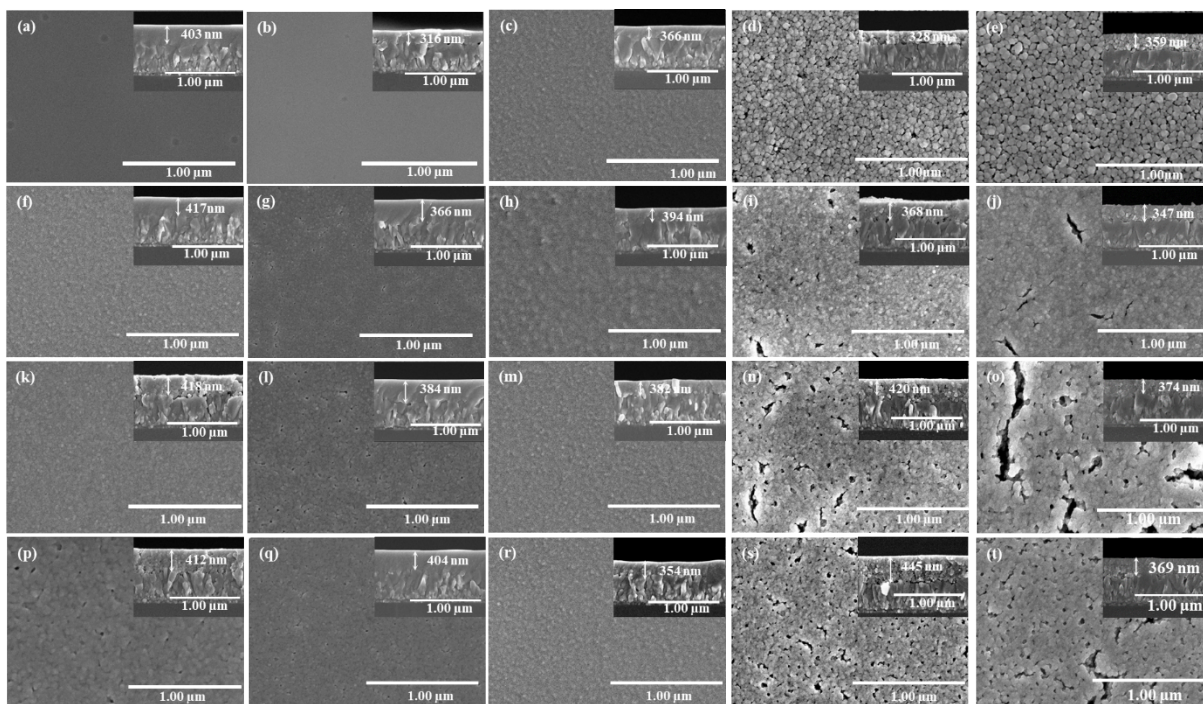
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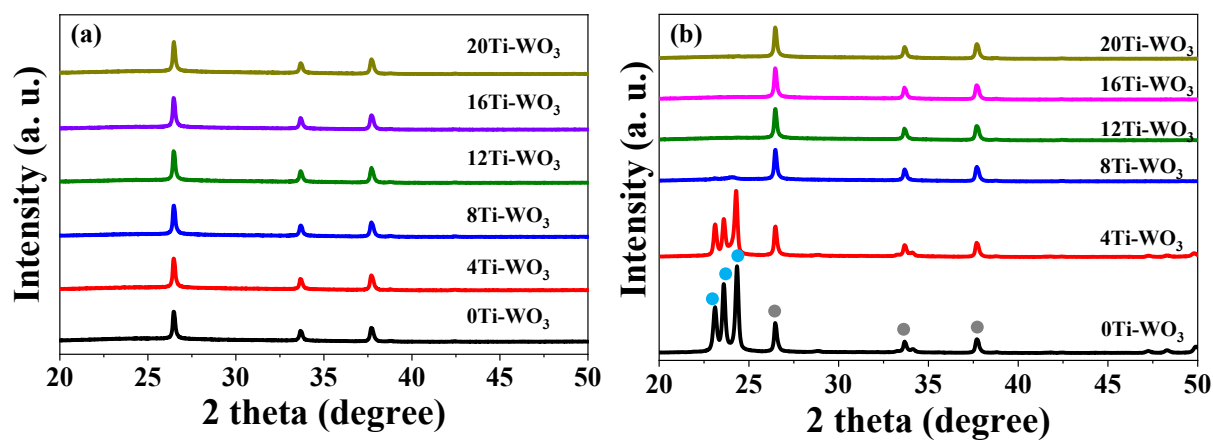
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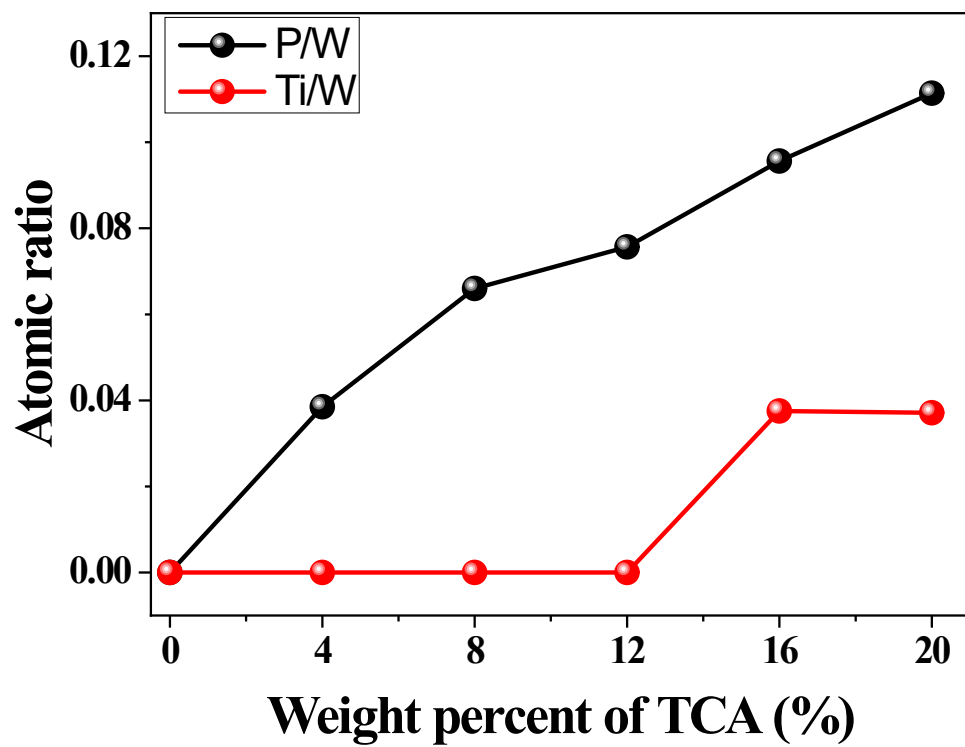
\*Corresponding author (C-H Cho., C.-H. Han., S-J Hong.)



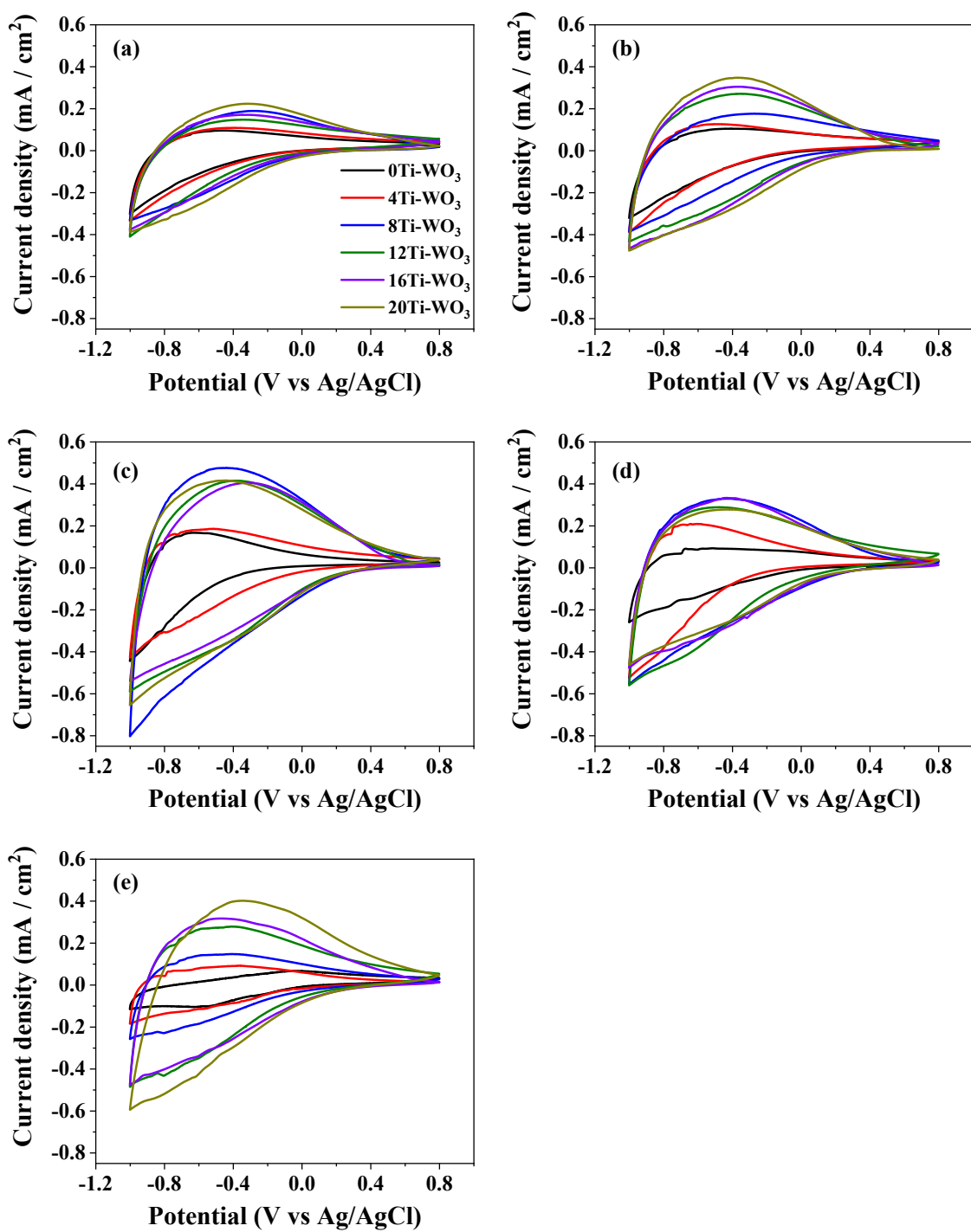
**Figure S1.** SEM surface and cross-sectional images of (1<sup>st</sup> row) 4Ti-WO<sub>3</sub>, (2<sup>nd</sup> row) 12Ti-WO<sub>3</sub>, (3<sup>rd</sup> row) 16Ti-WO<sub>3</sub> and (4<sup>th</sup> row) 20Ti-WO<sub>3</sub> films annealed at 200, 250, 300, 350 and 400 °C from left to right, respectively.



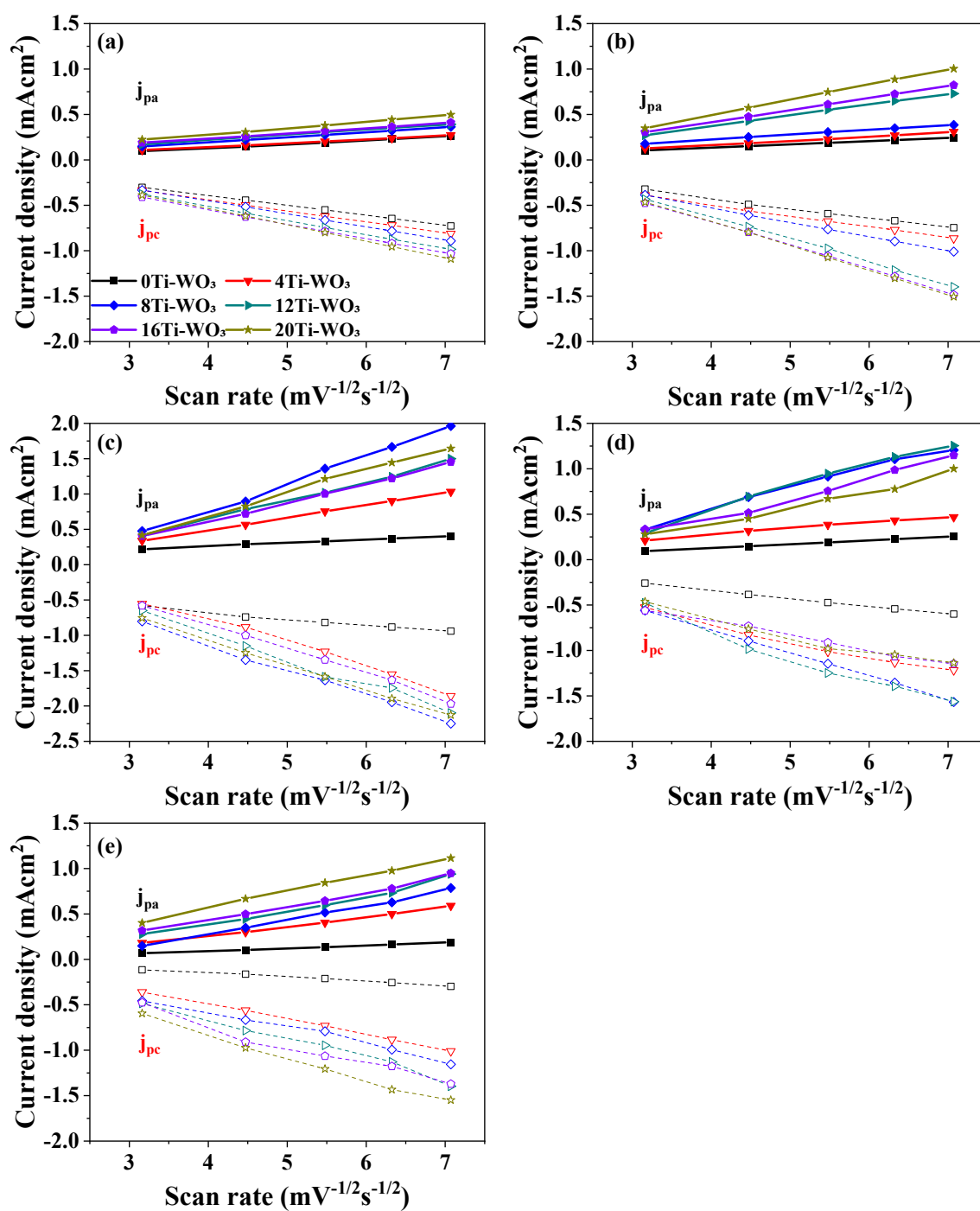
**Figure S2.** XRD patterns of neat and respective TCA doped WO<sub>3</sub> films annealed at (a) 250 and (b) 350 °C. (The light blue and grey circles refer to monoclinic WO<sub>3</sub> and FTO substrate, respectively.)



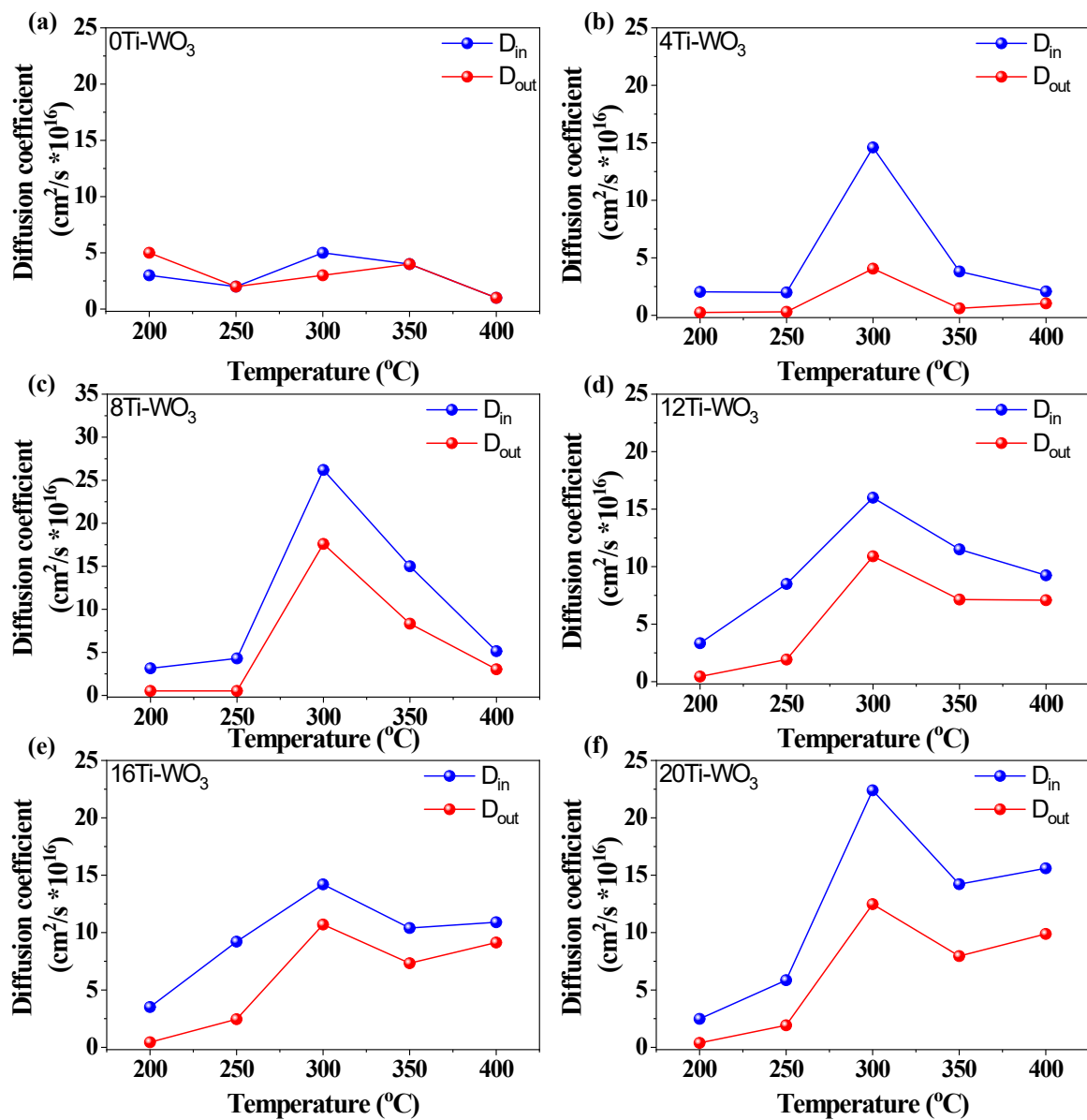
**Figure S3.** Atomic ratios of P/W or Ti/W for  $x\text{Ti-WO}_3\text{-300}$  samples determined with EDS.



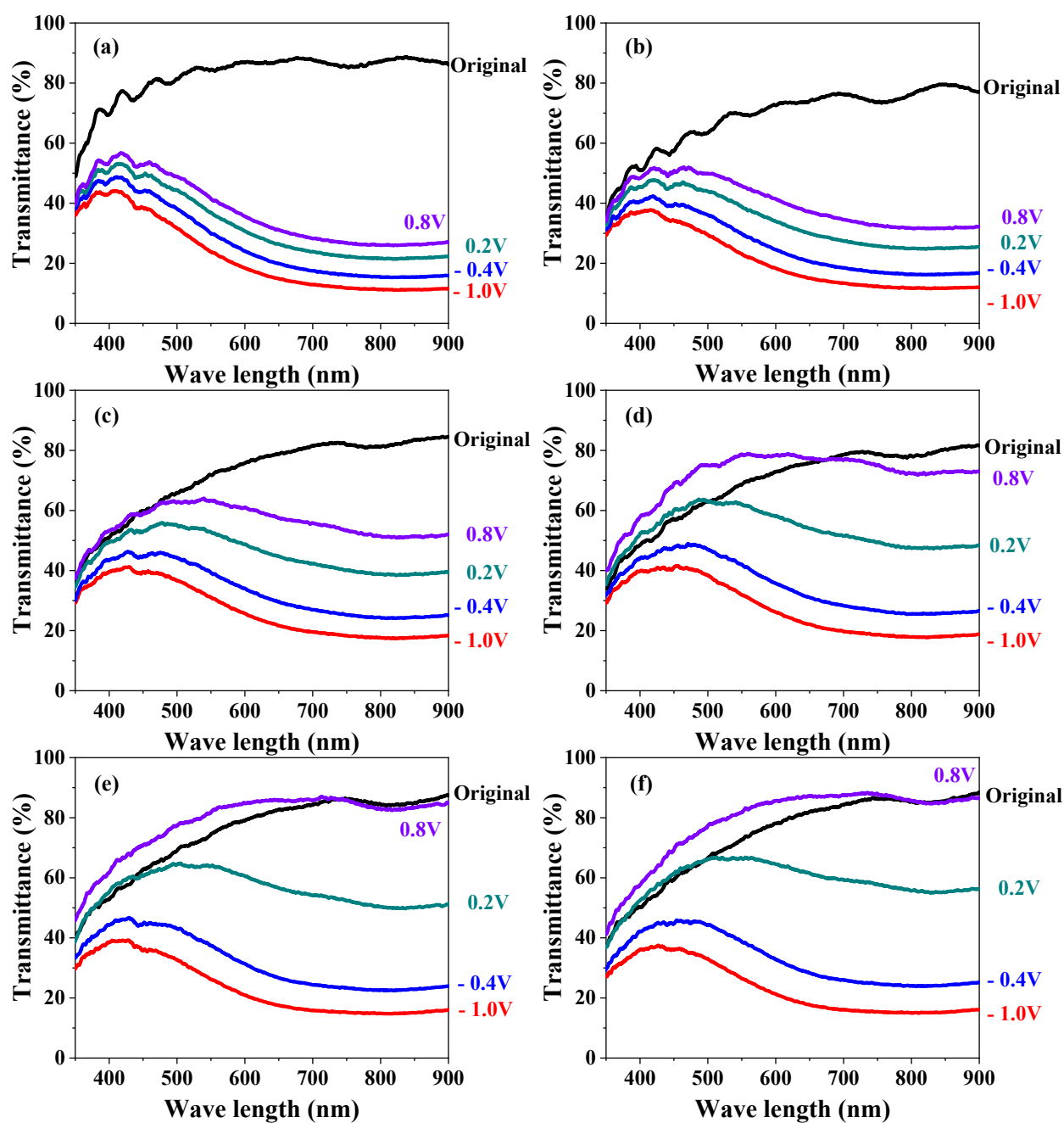
**Figure S4.** Cyclic voltammograms of various WO<sub>3</sub> films annealed at (a) 200, (b) 250, (c) 300, (d) 350, and (e) 400 °C, respectively.



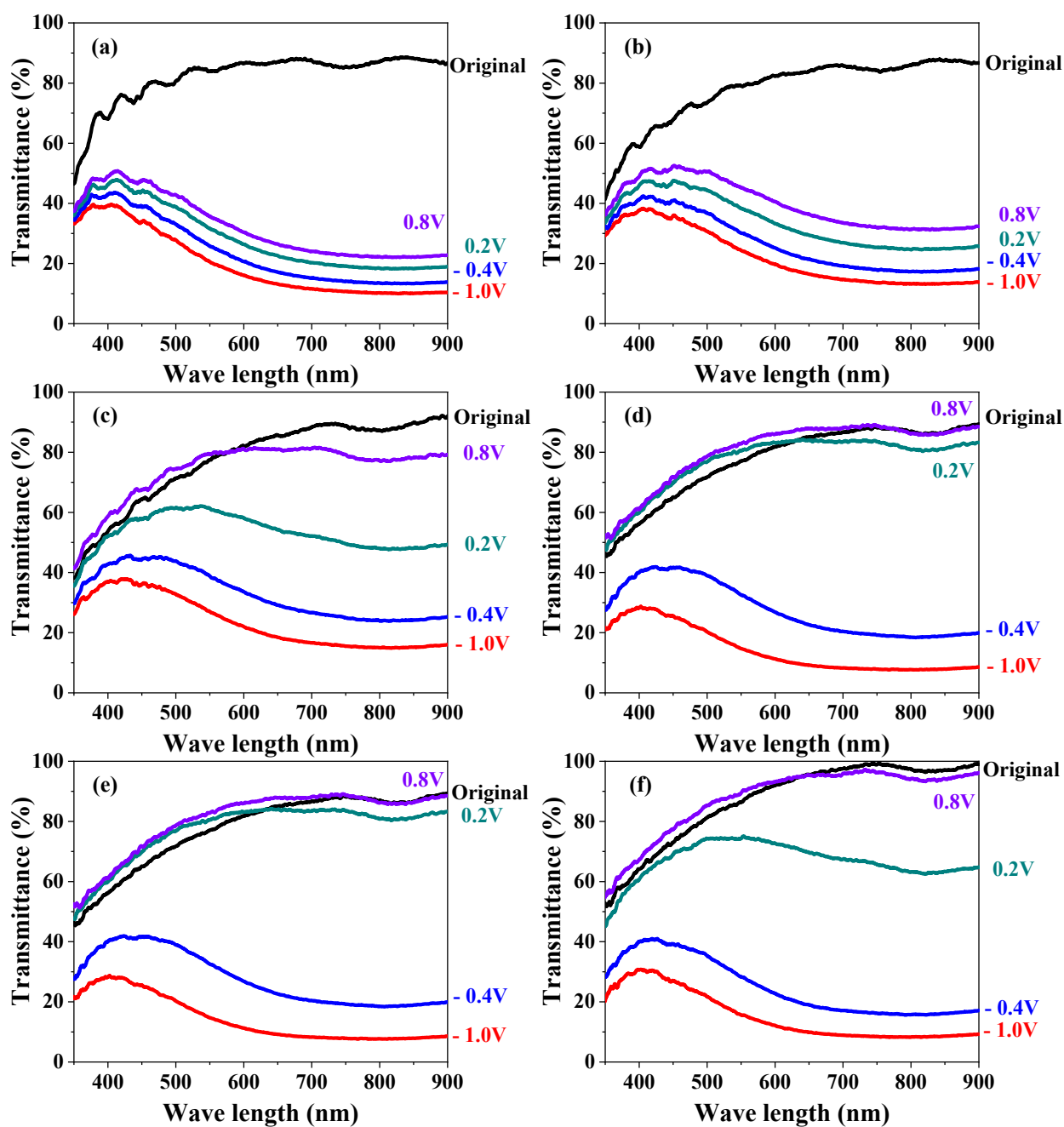
**Figure S5.** Calculations of diffusion coefficients of various WO<sub>3</sub> films annealed at (a) 200, (b) 250, (c) 300, (d) 350, and (e) 400 °C, respectively.



**Figure S6.** Calculated diffusion coefficients of (a) 0Ti-WO<sub>3</sub>, (b) 4Ti-WO<sub>3</sub>, (c) 8Ti-WO<sub>3</sub>, (d) 12Ti-WO<sub>3</sub>, (e) 16Ti-WO<sub>3</sub>, and (f) 20Ti-WO<sub>3</sub> at various annealing temperatures.

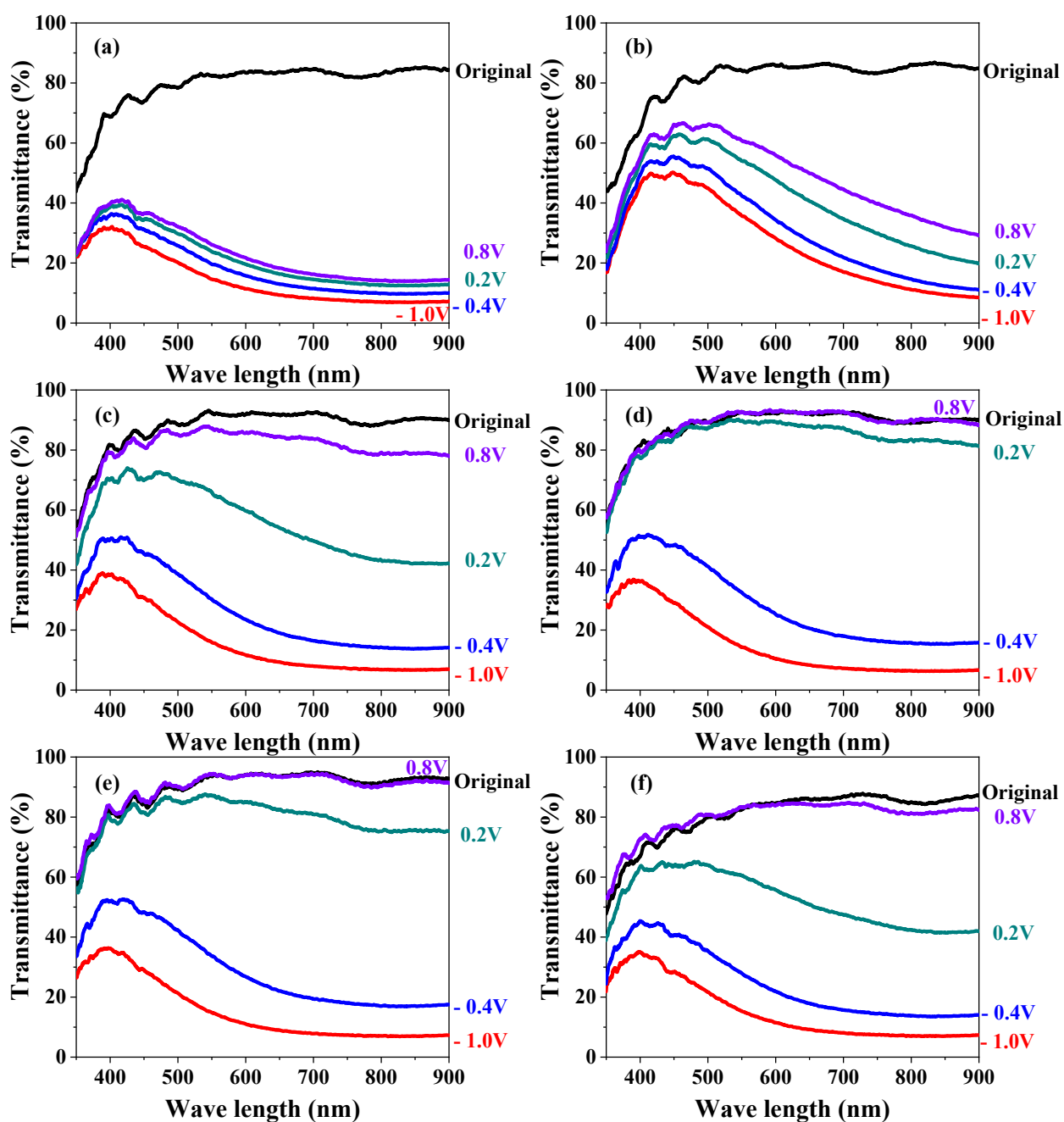


**Figure S7.** In-situ UV-Visible transmittance variations for (a) 0Ti-WO<sub>3</sub>-200, (b) 4Ti-WO<sub>3</sub>-200, (c) 8Ti-WO<sub>3</sub>-200, (d) 12Ti-WO<sub>3</sub>-200, (e) 16Ti-WO<sub>3</sub>-200, and (f) 20Ti-WO<sub>3</sub>-200, respectively.

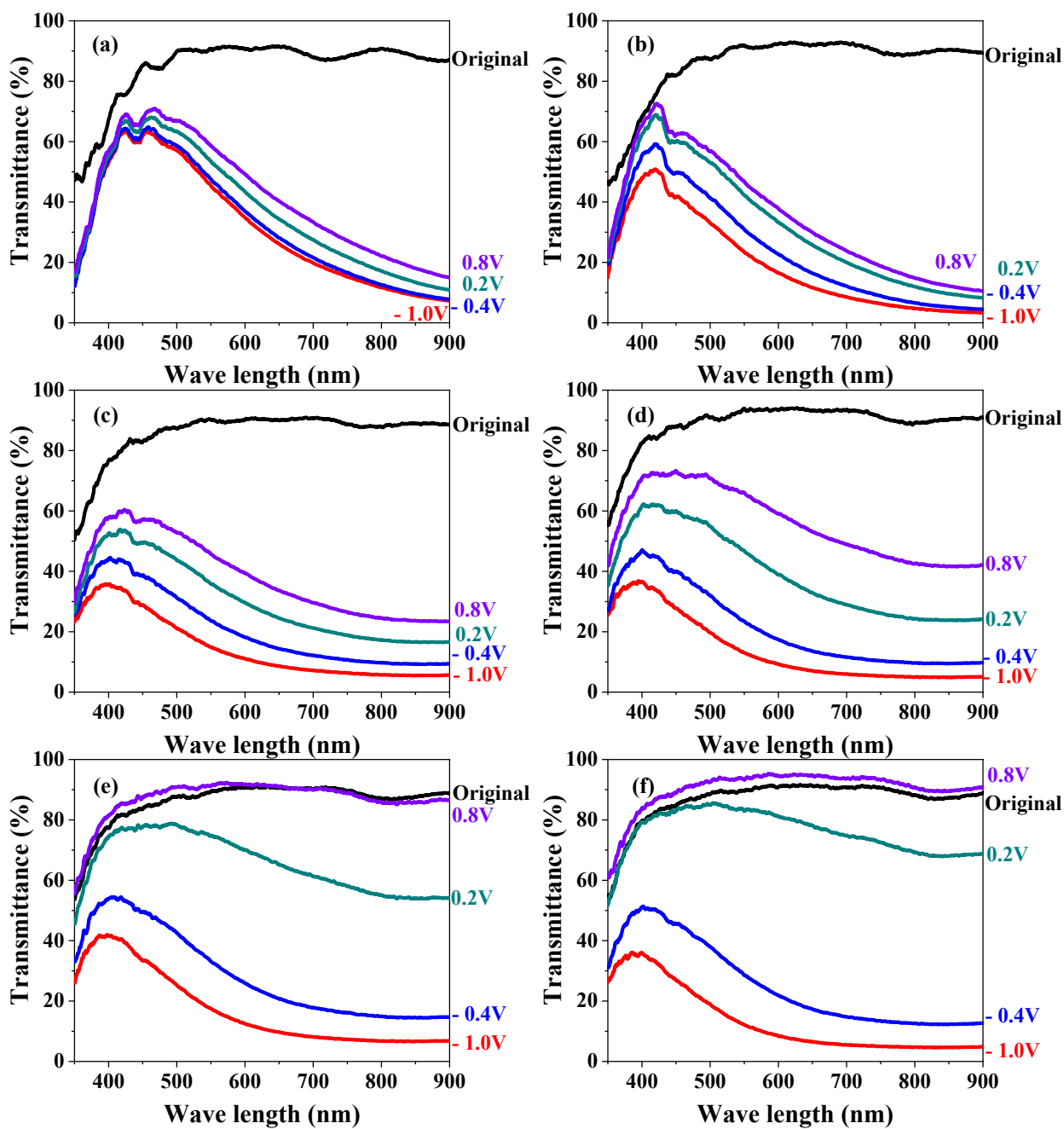


**Figure S8.** In-situ UV-Visible transmittance variations for (a) 0Ti-WO<sub>3</sub>-250, (b) 4Ti-WO<sub>3</sub>-250, (c) 8Ti-WO<sub>3</sub>-250, (d) 12Ti-WO<sub>3</sub>-250, (e) 16Ti-WO<sub>3</sub>-250, and (f) 20Ti-WO<sub>3</sub>-250, respectively.

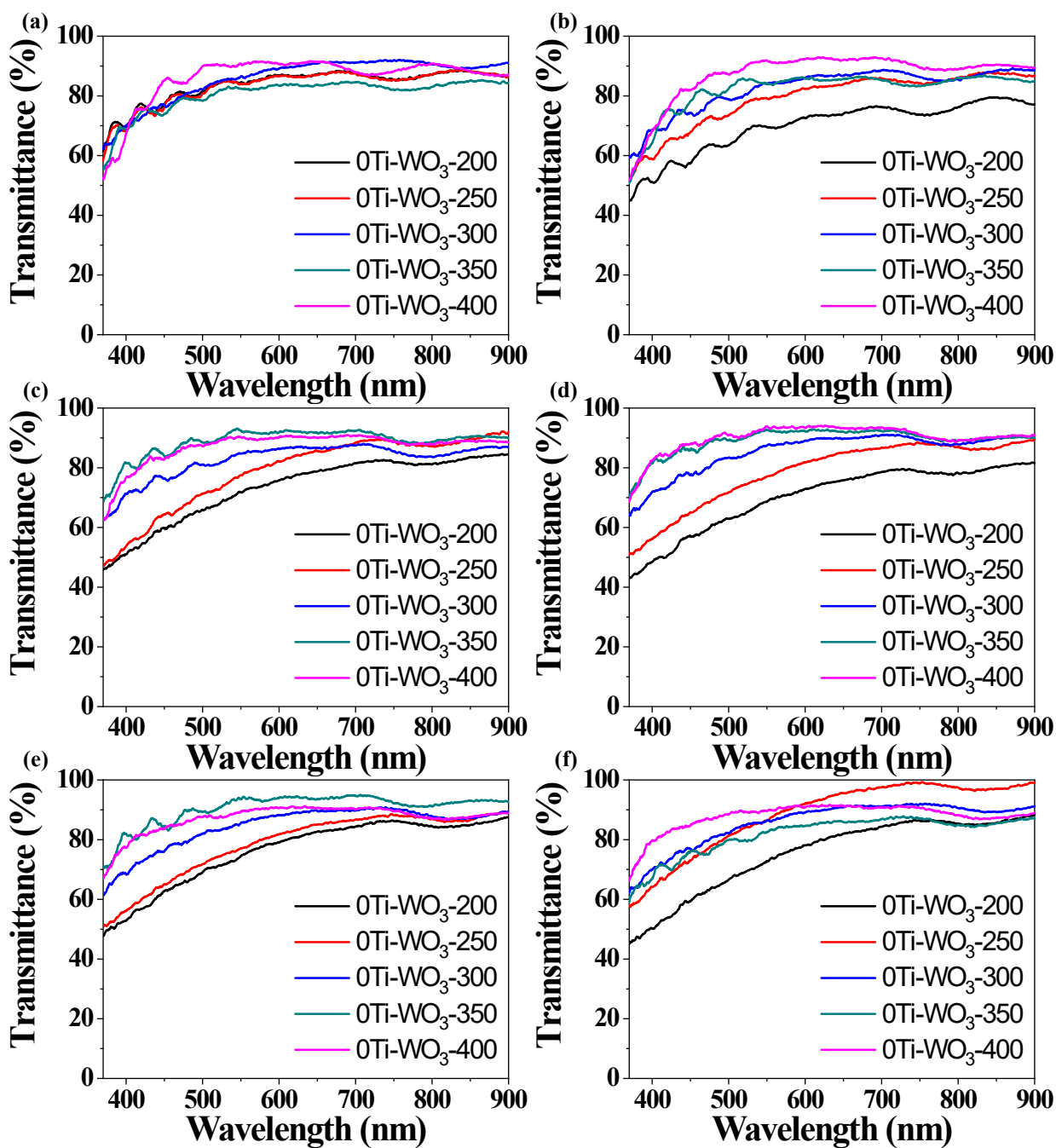




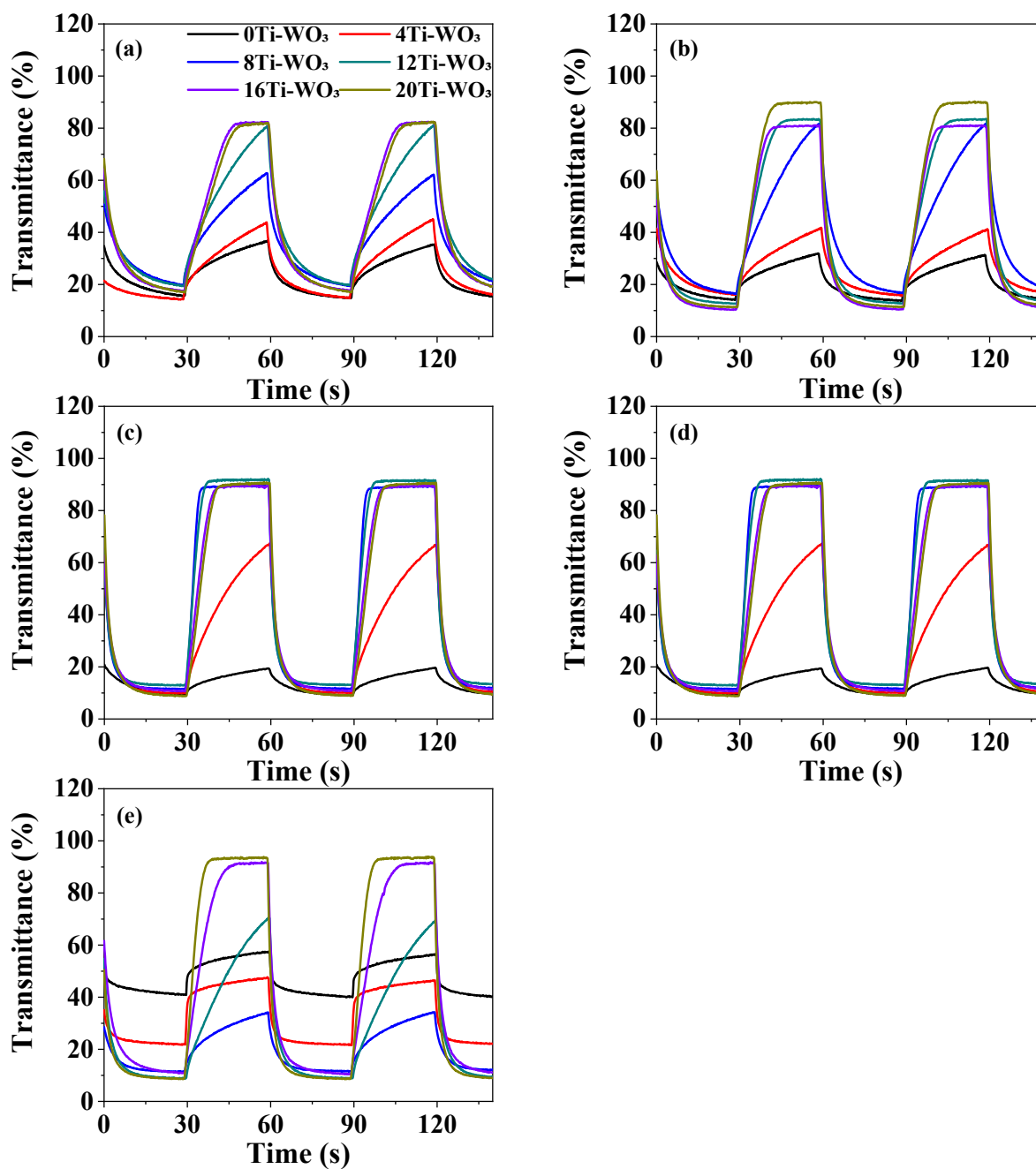
**Figure S9.** In-situ UV-Visible transmittance variations for (a) 0Ti-WO<sub>3</sub>-350, (b) 4Ti-WO<sub>3</sub>-350, (c) 8Ti-WO<sub>3</sub>-350, (d) 12Ti-WO<sub>3</sub>-350, (e) 16Ti-WO<sub>3</sub>-350, and (f) 20Ti-WO<sub>3</sub>-350, respectively.



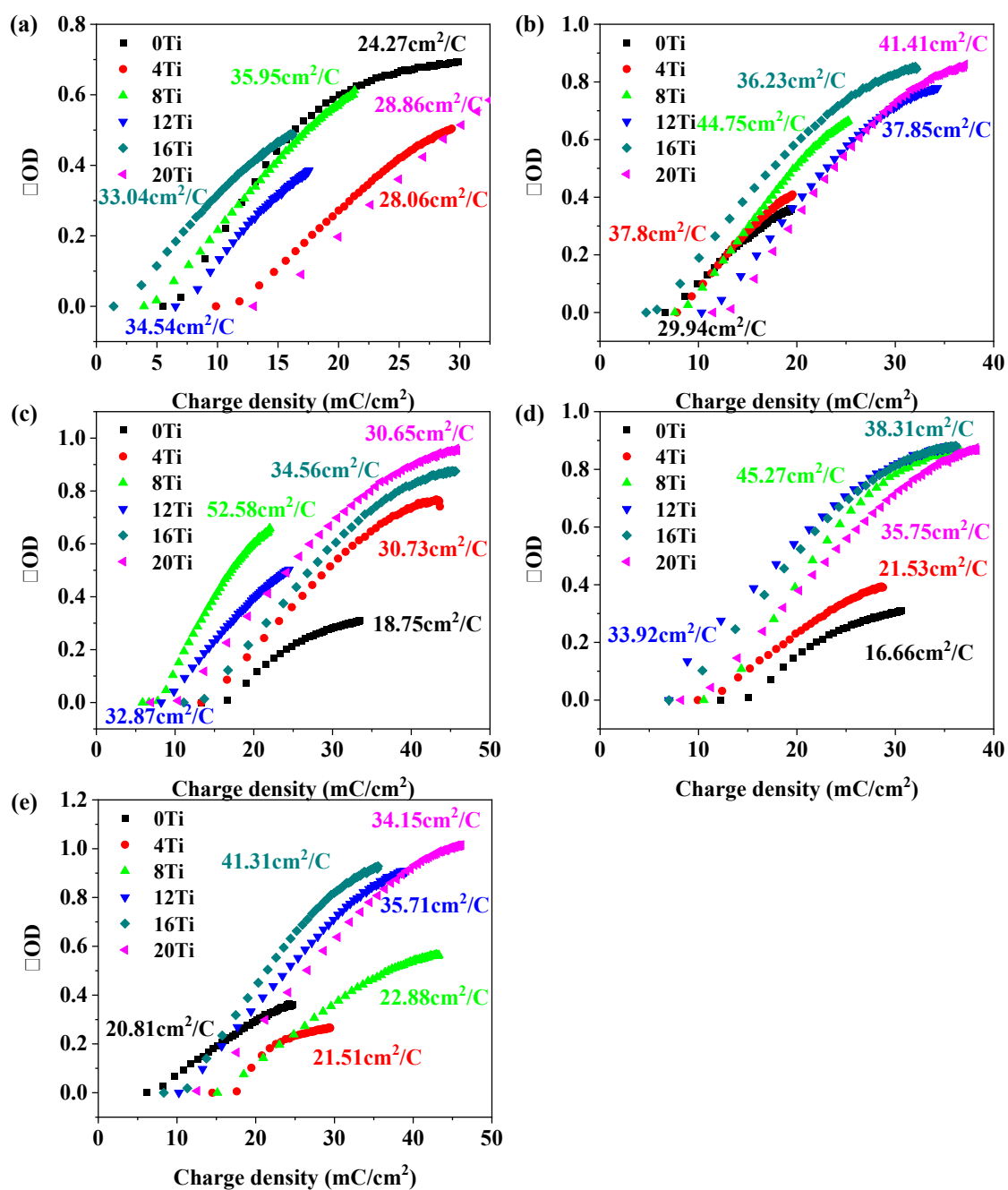
**Figure S10.** In-situ UV-Visible transmittance variations for (a) 0Ti-WO<sub>3</sub>-400, (b) 4Ti-WO<sub>3</sub>-400, (c) 8Ti-WO<sub>3</sub>-400, (d) 12Ti-WO<sub>3</sub>-400, (e) 16Ti-WO<sub>3</sub>-400, and (f) 20Ti-WO<sub>3</sub>-400, respectively.



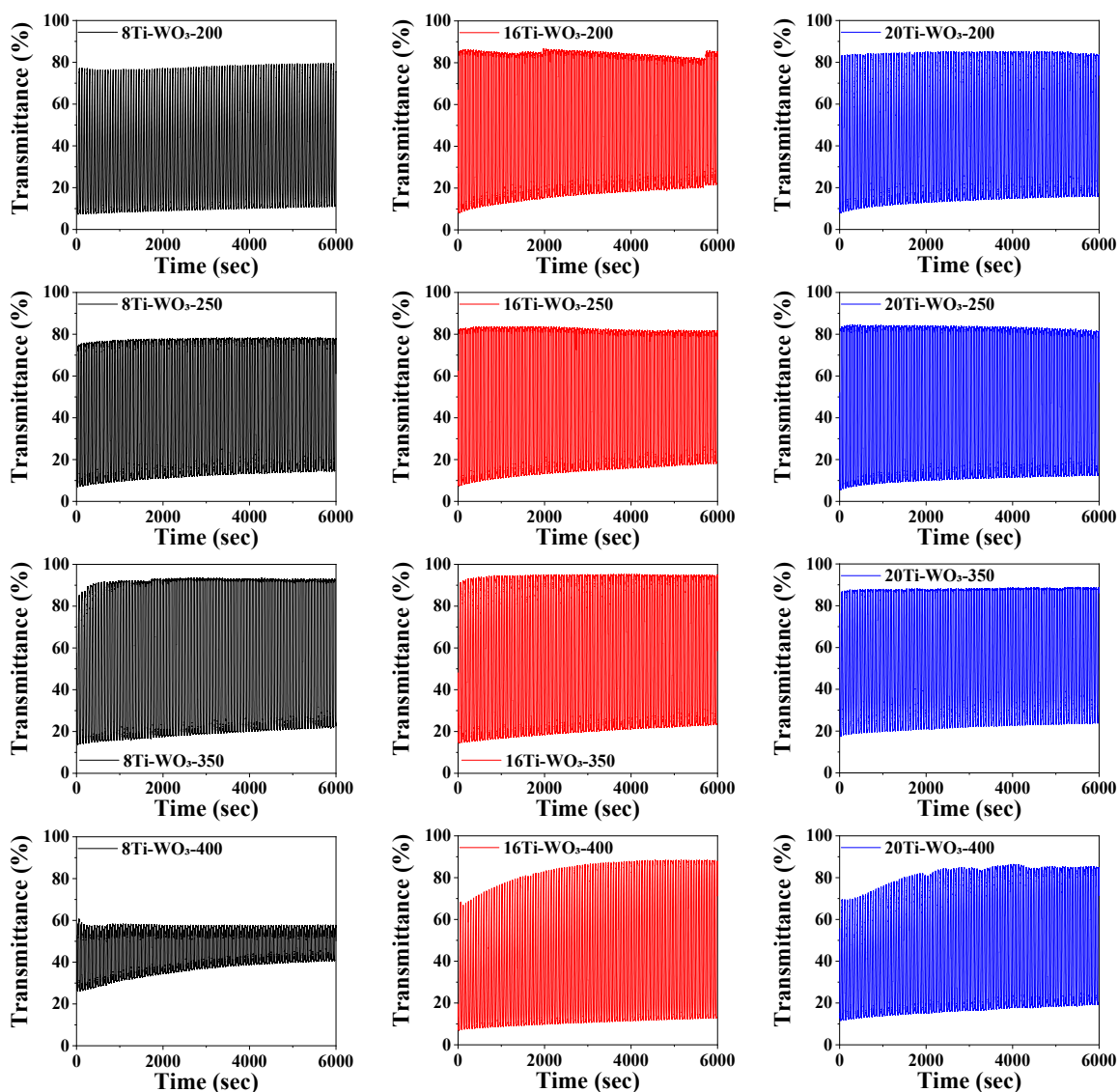
**Figure S11.** UV-Visible transmittance spectra of (a) 0Ti-WO<sub>3</sub>, (b) 4Ti-WO<sub>3</sub>, (c) 8Ti-WO<sub>3</sub>, (d) 12Ti-WO<sub>3</sub>, (e) 16Ti-WO<sub>3</sub>, and (f) 20Ti-WO<sub>3</sub> at the pristine states under different annealing temperatures.



**Figure S12.** *In situ* optical response of the WO<sub>3</sub> films for 60 s per step measured at 550 nm annealed at (a) 200, (b) 250, (c) 300, (d) 350, and (e) 400 °C.



**Figure S13.** Optical density variation with respect to the charge density of  $\text{WO}_3$  films annealed at (a) 200, (b) 250, (c) 300, (d) 350, and (e) 400 °C.



**Figure S14.** In-situ transmittance variation at  $\lambda=550$  nm during cyclic tests for 8Ti-, 16Ti- and 20Ti-WO<sub>3</sub>-films from left to right annealed at 200 (1<sup>st</sup> row), 250 (2<sup>nd</sup> row), 350 (3<sup>rd</sup> row) and 400 °C (4<sup>th</sup> row).